

ABSTRACT OF THE DISCLOSURE

A composition for sealing a semiconductor device contains polyphenylene sulfide wherein a line expansion coefficient at 150°C to 200°C is  $4.75 \times 10^{-5}$  [1/°C] or less, a line thermal expansion coefficient at 80 to 130°C is  $6.0 \times 10^{-5}$  [1/°C] or less, and a line expansion coefficient ratio between the flow direction and a normal direction of the flow direction is 0.55 or more.

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